

Monitoring of relevant process parameters using fluid sensors

Bernhard Wieser, M.Sc.

April 2020



Notes on this webinar



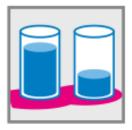
- This webinar is being recorded!
- If you would like to receive the presentation and / or the recording afterwards, we ask for your consent in accordance with the GDPR!



https://s.sick.com/newsletter_registration_at-de

















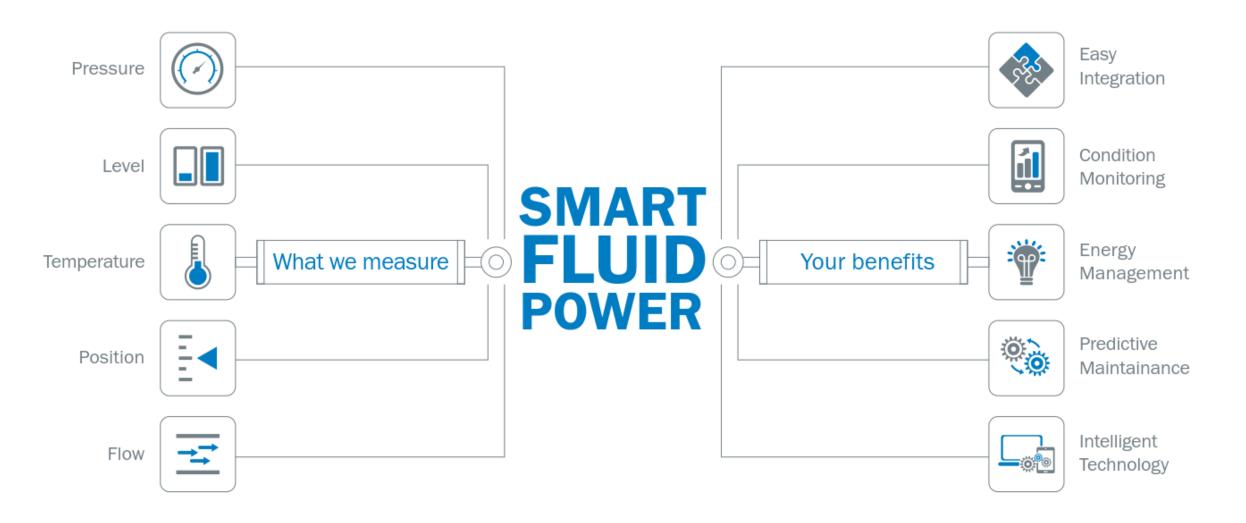




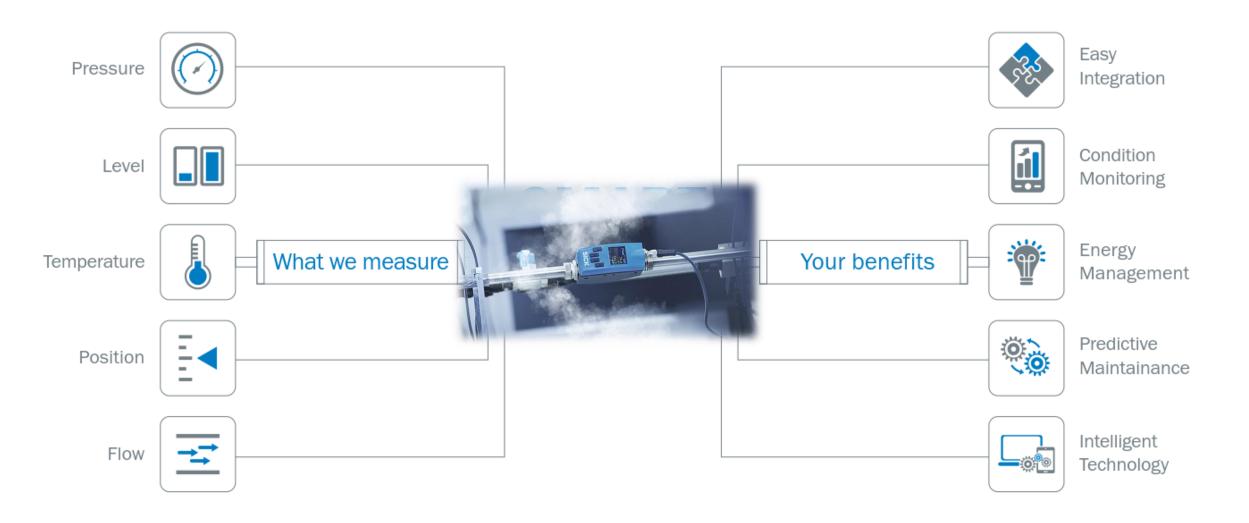
- Technology update as the basis for increasing efficiency for the relevant process parameters:
 - Level and point level measurement
 - Universal pressure measurement in liquids and gases
 - Flow measurement technology
 - Temperature measurement for liquids and gases
- Technology selection
- Process connections
- Outlook 80 Ghz radar technology





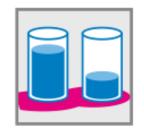






Level and point level measurement

Overview of technologies





Level measurement for all possibilities of liquids and bulk goods:

Guided Radar Wave (TDR)

Ultrasonic

Capacitive

Hydrostatic

Free space radar (e.g. 80 GHz)

Point level measurement:

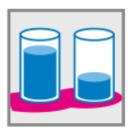
vibration

Visually

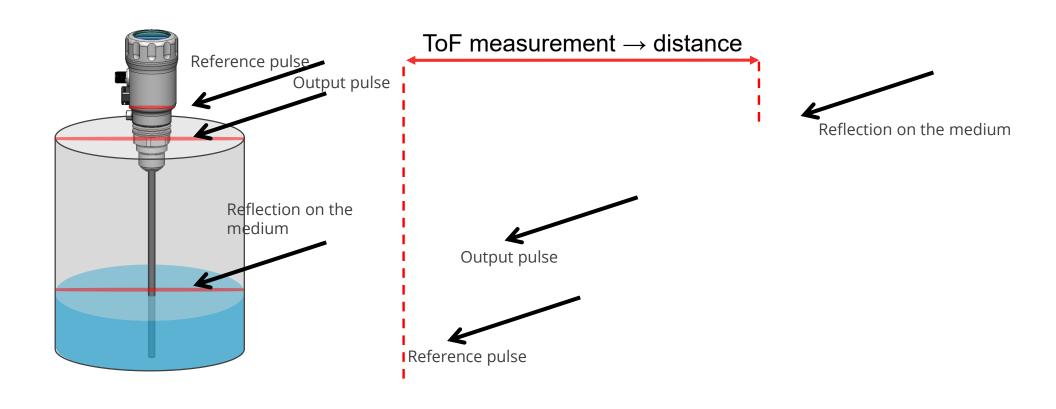
Capacitive impedance spectroscopy



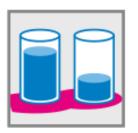
Guided Radar Wave (TDR)



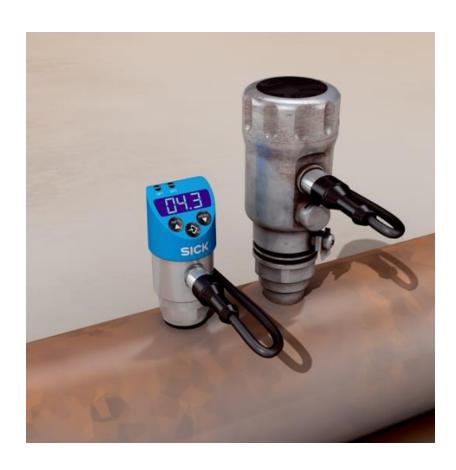




Guided Radar Wave (TDR)









Ultrasonic

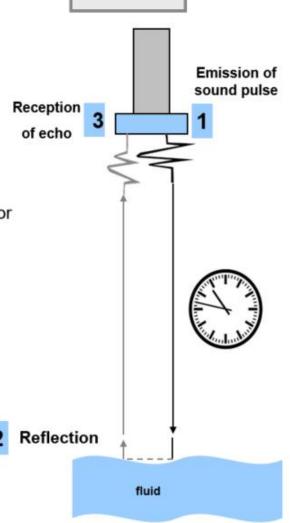


Ultrasonic sensors work based on time of flight principle

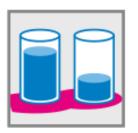
- Emission of sound pulse
- 2. Reflection
- 3. Reception of echo

Based on the run time of the emitted sound pulse the sensor determines the distance between the fluid and the sensor





Ultrasonic



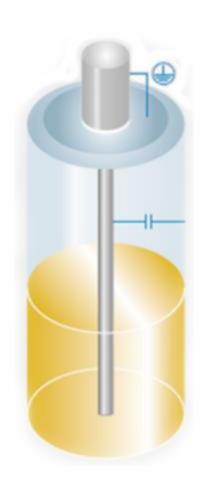


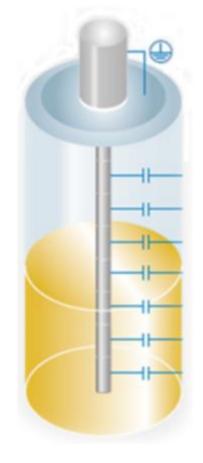


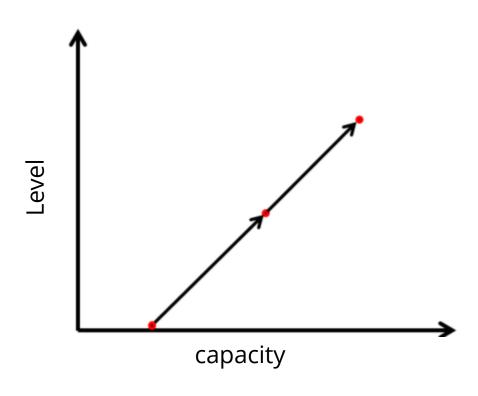
Capacitive



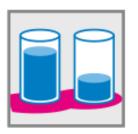




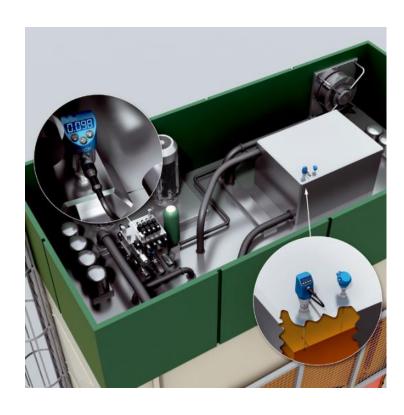




Capacitive

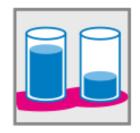








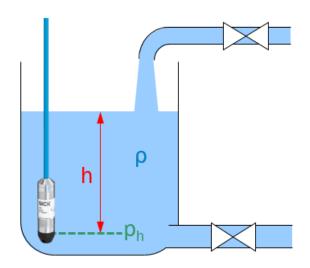
Hydrostatic open tank





Because of its mass any liquid is creating pressure. This pressure depends on the height of the liquid level and it can be used for level measurement.

Open tank

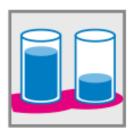


$$h = \frac{p_h}{\rho \cdot g}$$

- h height of level above pressure sensor
- p_h gauge pressure in depth h
- p density of liquid
- g acceleration of gravity (9.81 m/s^2) .

Rule of thumb

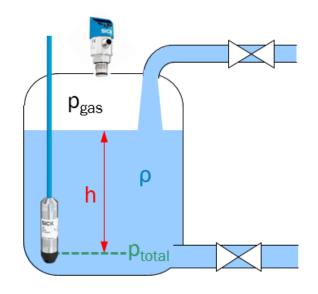
Hydrostatic closed/pressurized tank





In a pressurised tank the pressure of the gas above the liquid excerts pressure on the liquid's level. For the calculation of the level this pressure must be subtracted to obtain the hydrostatic pressure.

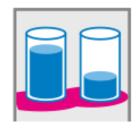
Closed/Pressurized tank



$$h = \frac{p_{total} - pgas}{p \cdot g}$$

- height of level above pressure sensor
- p_{total} total gauge pressure in depth h
- $p_{\text{gas}}\,$ gauge pressure of gas above level
- density of liquid
- acceleration of gravity (9,81 m/s²).

Hydrostatic closed/pressurized tank





Attention:

The accuracy of hydrostatic level measurement in pressurized tanks is higher than in open tanks. This is because in pressurized tanks the combined accuracy of 2 pressure sensors has to be taken into account.

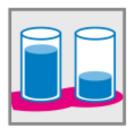
Open tank: One pressure sensor

$$h = \frac{p_h}{\rho \cdot g}$$

Pressurized tank: Two pressure sensors

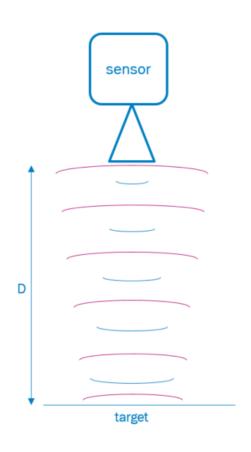
$$h = \frac{p_{total} - p_{gas}}{\rho \cdot g}$$

Radar free space (e.g. 80 GHz)





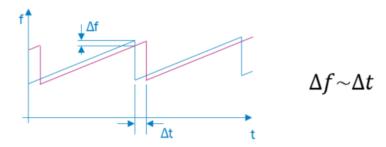
FMCW (Frequency Modulated Continuous Wave) radar technology



- Radar signal gets emmitted by antenna
- Radar signal gets reflected by target back to antenna
- Time between emmitting and receiving the signal (travel time) is directly proportional to distance to target

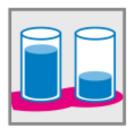
$$D = \frac{c_{gas\ phase} \cdot \Delta t}{2}$$

Since such short times are difficult to measure accurately FMCW uses Frequeny Modulation and mixes both signals



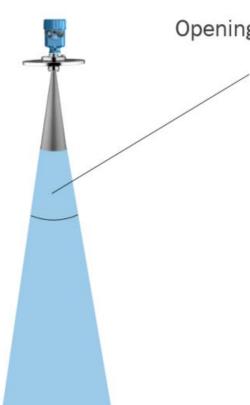
The resulting frequency is the difference of the frequency of both signals and indirectly corresponds to the time difference which indicates the distance

Radar free space (e.g. 80 GHz)





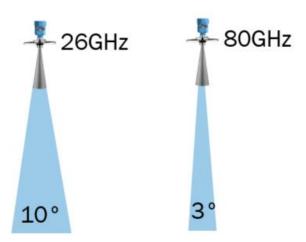
80GHz – the meaning of the frequency



Opening angle:

$$\propto = 70^{\circ} \cdot \frac{speed\ of\ light}{antenna\ diameter \times frequency}$$

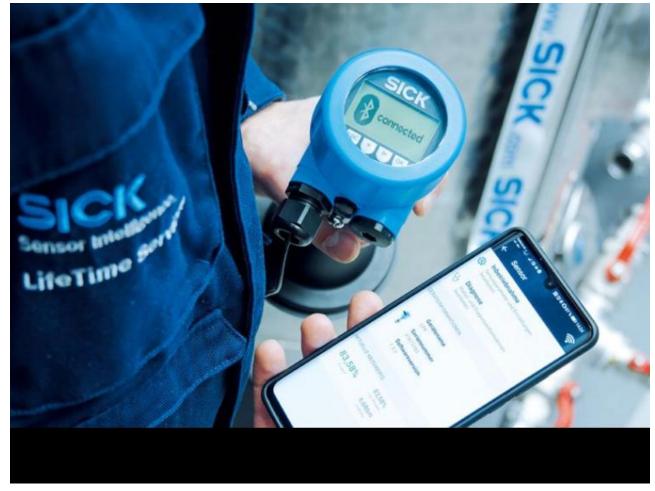
→ For same antenna size: As higher the frequency as better the focusing As better the focusing as less disturbances



Radar free space (e.g. 80 GHz)

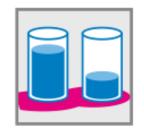






Level and point level measurement

Overview of technologies





Level measurement for all possibilities of liquids and bulk goods:

Guided Radar Wave (TDR)

Ultrasonic

Capacitive

Hydrostatic

Free space radar (e.g. 80 GHz)

Point level measurement:

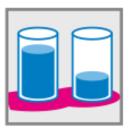
vibration

Visually

Capacitive impedance spectroscopy



Vibration





- Tuning fork technology
 - Acoustic technology
 - A fork vibrates in resonance frequency
 - Immersing the fork in substance changes the resonance
- Background
 - ► Liquids or solids influence the resonance of the tuning fork
 - ► Changes to the resonance trigger a switching signal
- Structure with piezo elements



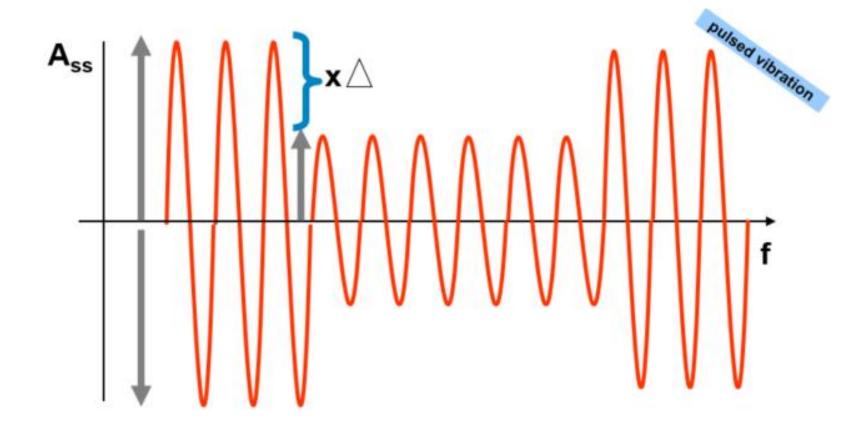


Input (e.g., striking the fork)

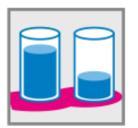
Vibration



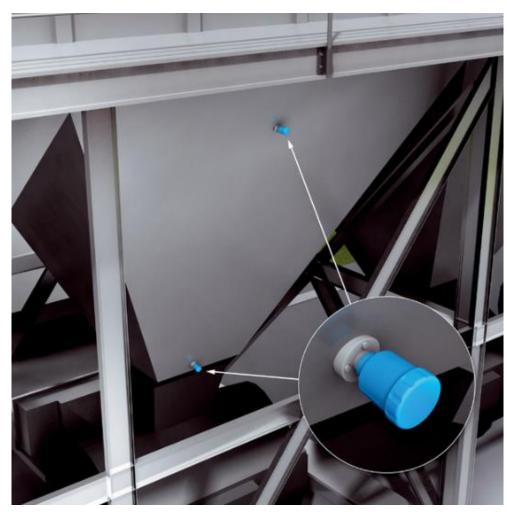




Vibration









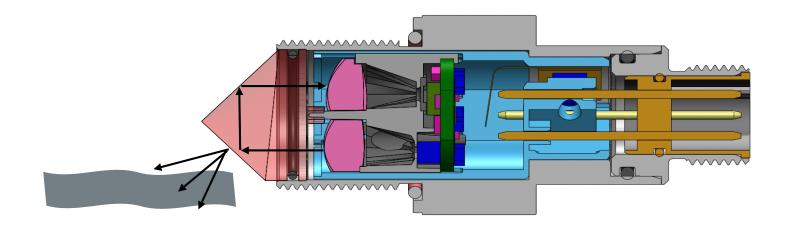
Monitoring of relevant process parameters using fluid sensors, Bernhard Wieser, M.Sc., Webinar

Optical

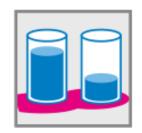








Optical





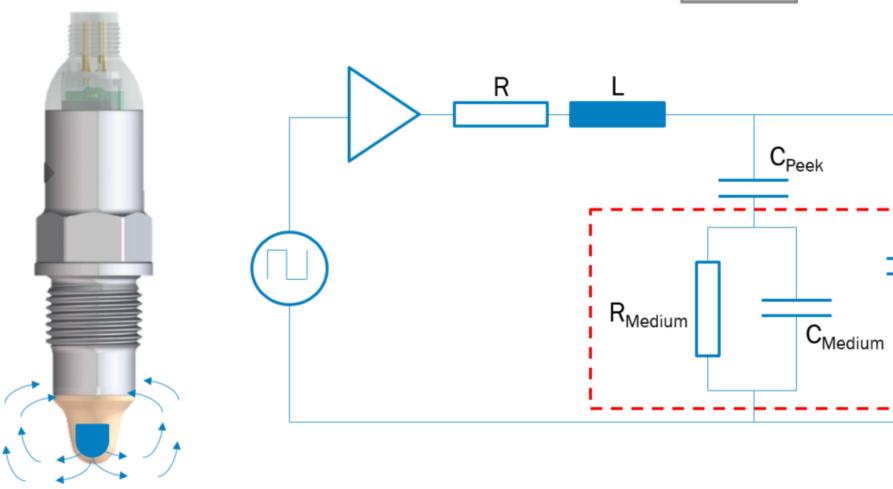


Capacitive impedance spectroscopy

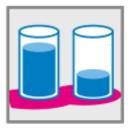




 C_Ref



















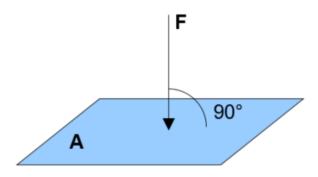


- **Technology update as the basis for increasing efficiency** for the relevant process parameters:
 - Level and point level measurement
 - Universal pressure measurement in liquids and gases
 - Flow measurement technology
 - Temperature measurement for liquids and gases
- **Technology selection**
- **Process connections**
- **Outlook 80 Ghz radar technology**









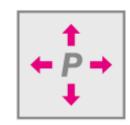
$$p = \frac{F}{A}$$

$$[p] = \frac{N}{m^2} = Pa (Pascal)$$



French scholar Blaise Pascal (June 19, 1623 to Aug. 19, 1662)

Unit



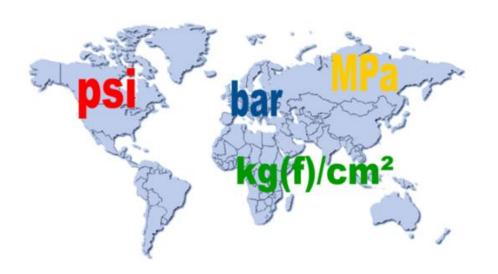
SICKSensor Intelligence.

■ 1 bar = **100 000 Pa**

■ 1 psi = 1 lbf / in² = **6.895 Pa**

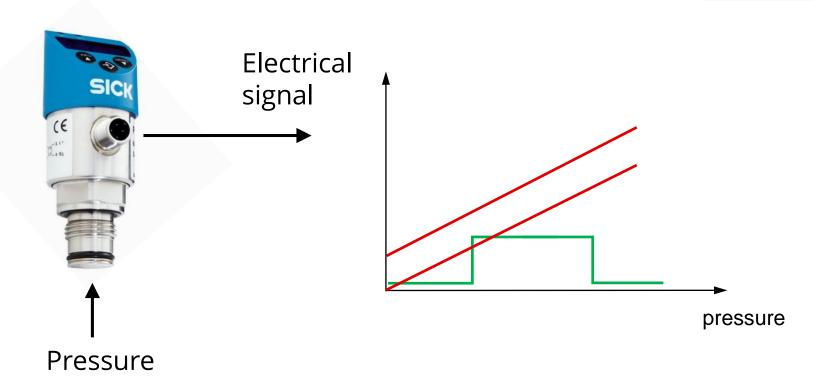
■ 1 MPa = **1 000 000 Pa** = 10 bar

■ $1 \text{ kg(f)/cm}^2 = 98067 \text{ Pa} = 0.981 \text{ bar}$

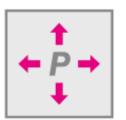




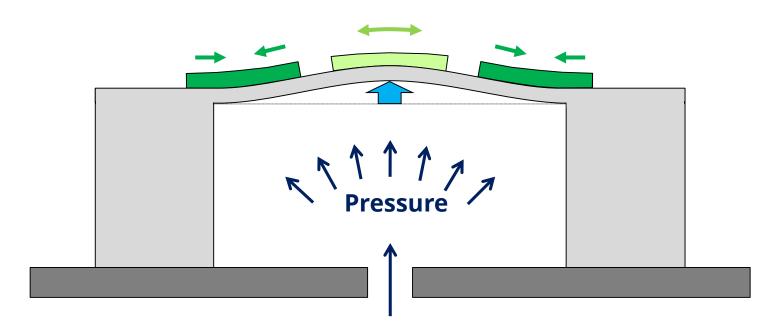


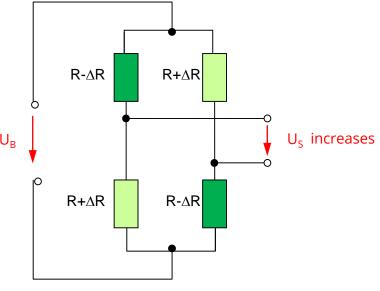


- Pressure transmitter → analog output signal
- Pressure switch → digital output signal

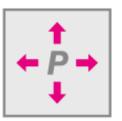








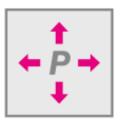
Processconnection



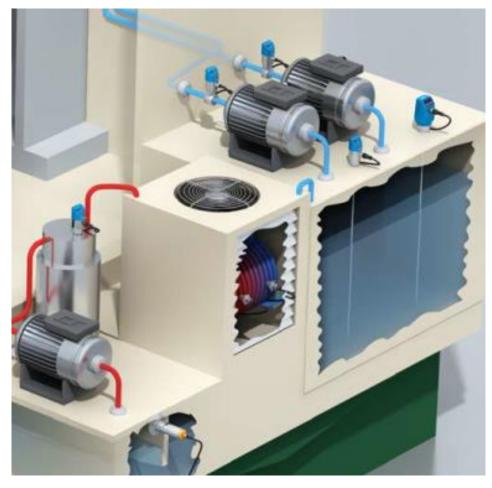




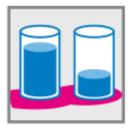
Application control of workpiece clamping





















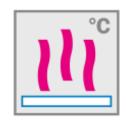




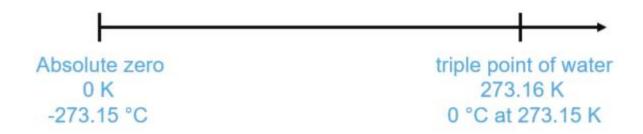
- Technology update as the basis for increasing efficiency for the relevant process parameters:
 - Level and point level measurement
 - Universal pressure measurement in liquids and gases
 - Flow measurement technology
 - Temperature measurement for liquids and gases
- Technology selection
- Process connections
- Outlook 80 Ghz radar technology



Temperature









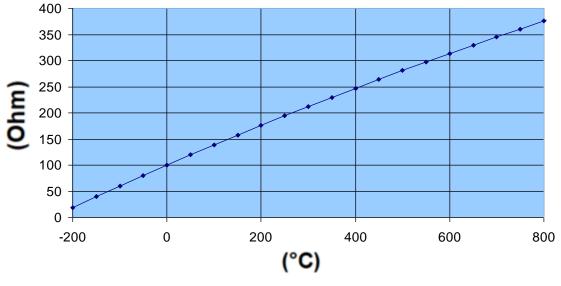
Anders Celsius

Temperature

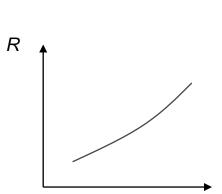
Platinum resistance











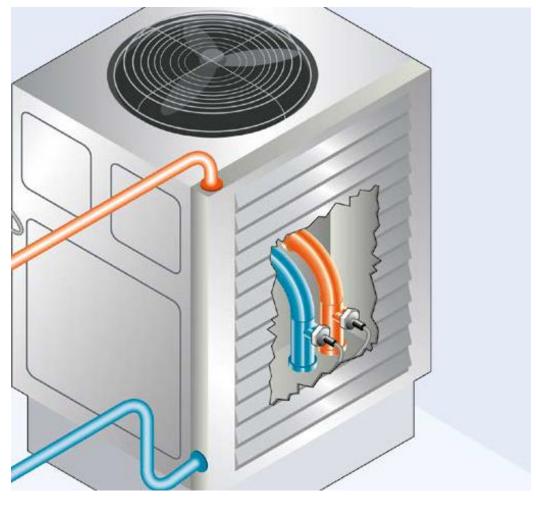


Temperature

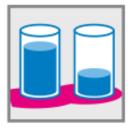
Application coolant temperature control

























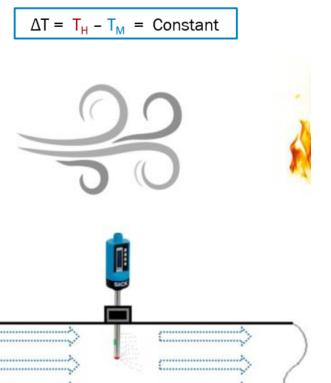
- Technology update as the basis for increasing efficiency for the relevant process parameters:
 - Level and point level measurement
 - Universal pressure measurement in liquids and gases
 - Flow measurement technology
 - Temperature measurement for liquids and gases
- Technology selection
- Process connections
- Outlook 80 Ghz radar technology

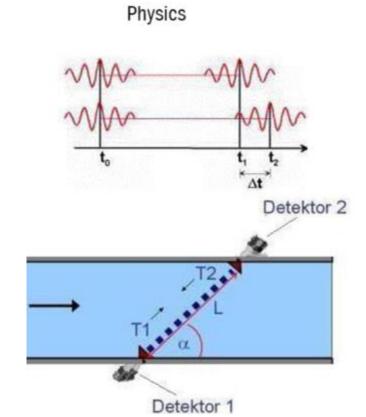


Flow







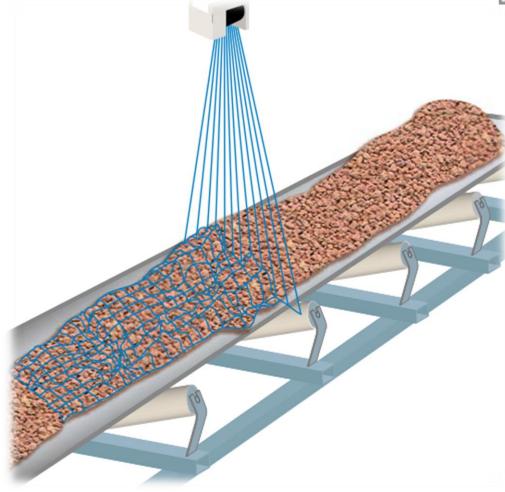


Flow

Application volume information







Flow

Application volume information





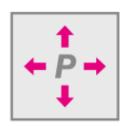




New Innovation









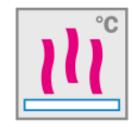




New Innovation → FTMg











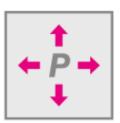




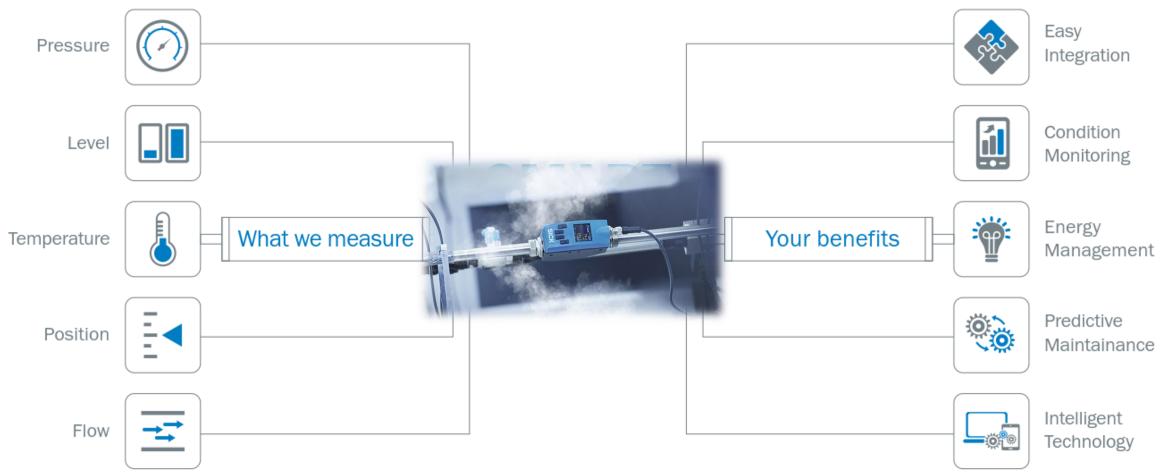
New Innovation → FTMg









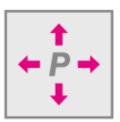


Sensor breakfast

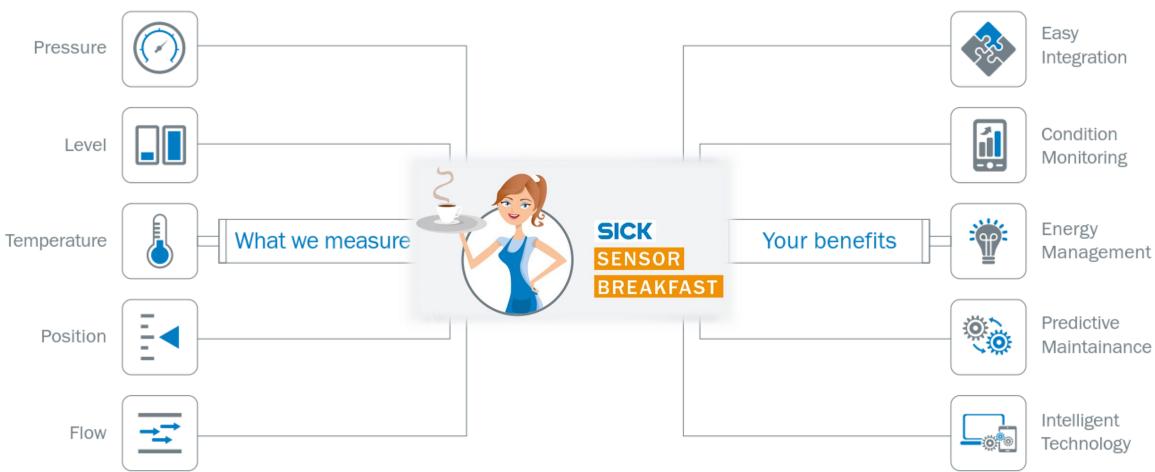












Online configurator

https://www.sick.com/





I am looking for

Product Know How

DOWNLOADS

MY SICK

Application Know How

Home & Droduct portfolio & Fluid cancore & Level cancore & LRD SicWave



Fluid sensors

PRODUCTS

Optimized control of process parameters is the main driver for increasing efficie and reducing input of valuable resources. Whether it's pressure measurement, temperature measurement, level control or flow metering - SICK offers a wide of solutions for measuring process variables for liquids, gases and bulk solids ar protecting against overfill and dry run. SICK devices are rugged and easy to use Innovative sensor technology enables accurate, universal measurement indeper of material type.

Level sensors



Whether for continuous level measurement, point level measurement or both - SICK offers a wide range of solutions for process engineering, storage, and protection. Based on the installation ...

Flow sensors



SICK provides innovative sensor solutions for flow measurement technology which combine flexible measuring methods and rugged equipment design with costefficient connection concepts to ...

Pressure sensors

Temperature sensors

SICK offers a portfolio of electronic pressure measurement transmitters and switches that can be adapted to individu customer requirements because of intelligent and varied configuration ...

With its product portfolio of screw-in an insertion thermometers as well as temperature switches SICK offers highquality solutions for contact temperature measurement in liquids and gases. The

Level and point level measurement using efficient technology



The innovative offer comprises, for example, guided wave radar sensors (TDR), ultrasonic equipment, capacitive sensors, vibrating equipment and various optical technologies.

With SICK, the focus is on the optimum solution for your application, To achieve this, we can

Level measurement with LFP Inox

LFP Inox detects the level of storage containers in order to guarantee the supply to the filling machine Besides the aseptic design, the most important fea ture of this application is fast, precise measuremen

- · Fast response time
- High reproducibility
- Hygienic design
 High enclosure rating IP69
- Simple installation



Pressure measurement for liquids and gases



In many branches of machine and plant engineering, the production industry, machine tool construction, process technology, and the manufacture and refinement of foodstuffs and beverages, measurement of variable state pressure plays a central role.

Monitoring of the workpiece clamping by PBS plus with IO-Link

In CNC machines, the workpieces are often clamped hydraulically. Electronic pressure switches like the PBS make sure that the clamping pressure is correct.

- Benefits:
 Pressure switch, pressure transmitter and display in one device

 • Quick product changes through switching point
- setting via IO-Link
- Ergonomic: clearly legible display, large push buttons and rotating housing
- Rugged and reliable
- · Wide range of installation variants

ser temperature measurement

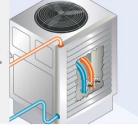


Whether it is the monitoring of operating conditions in machine and plant engineering or the control and regulation of sensitive processes, the reliable and accurate determination of tem-perature is of fundamental importance in many industries.

Cooling lubricant temperature control with

Temperature sensors are used in many areas. One example is the machine tool industry. Reliability and long-term stability of the thermometers are indispens the cooling lubricant is regulated in order to guarantee high quality machining of the workpiece

- Reliable
- Small dimension:
- Simple installation Inexpensive



Flow and throughput measurement with modern technologies

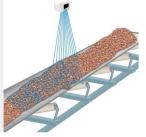


SICK flow rate sensor systems rely on innovative run-time measurement processes based on ultrasonic and laser technology. These non-contact technologies are particularly notable for their flexible fields of application and their great variety.

Bulkscan[®]

The non-contact measuring Bulkscan® device detects the profile of the bulk material on the conveyor belt. The flow rate is calculated using the belt speed and the bulk material profile. This makes it possible to create a feedback control system that provides ontimal belt speed and ensures economic belt utilization.

- Flexible use · Optimum belt usage
- Belt monitoring to reduce belt wear (Bulkscan® LMS511)







Thank you for your attention!

Bernhard Wieser

bernhard.wieser@sick.at www.sick.at

